

PATENT APPLICATION  
 Attorney's Do. No. 8371-129  
 Client Ref. No. SLA0571

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Apostolos Voutsas and Yukihiro Nakata  
 Serial No. 09/945,063 Examiner: G. L. Fournson III  
 Confirmation No. 3014  
 Filed: August 31, 2001 Art Unit: 2826  
 For: METHOD OF FORMING MULTI-LAYERS FOR A THIN FILM  
 TRANSISTOR(TFT) AND THE DEVICE FORMED THEREBY

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**TRANSMITTAL LETTER**

Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, VA 22313-1450

Responsive to the communication dated November 17, 2004, enclosed is an amendment in the above-identified application.

The fee has been calculated as shown below.

CLAIMS AS AMENDED					
For:	Number After Amendment	Previous Number	Extra	Rate	Additional Fee
Total Claims	19	19*	0	0x \$9 =	\$0
Independent Claims	2	2**	0	0x \$43 =	\$0
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0

\*greater of twenty (20) or number for which fee has been paid

\*\*greater of three (3) or number for which fee has been paid

Enclosed for filing in the above-referenced application are the following:

- ☒ Notice of Limited Recognition Under 37 CFR § 10.9(b).  
☒ Any deficiency or overpayment should be charged or credited to deposit account number 13-1703.

Customer No. 20575

Respectfully submitted,

MARGER JOHNSON & McCOLLOM, P.C.

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 Limited Recognition Under 37 CFR § 10.9(b)

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I hereby certify that this correspondence is being transmitted to the U.S. Patent and Trademark Office via facsimile number 703-872-9306, on November 29, 2004.

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Apostolos VOUTSAS and Yukihiro NAKATA

Serial No. 09/945,063 Examiner: George R. Fourson III

Filed: August 31, 2001 Art Unit: 2823

For: METHOD OF FORMING MULTI-LAYERS FOR A THIN FILM  
TRANSISTOR (TFT) AND THE DEVICE FORMED THEREBY

Confirmation No.: 3014

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Responsive to a communication, dated November 17, 2004 please amend the application as follows.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.